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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROKATSU MIYATA

Application No.: 09/657,616

Filed: September 8, 2000

For: MESOSTRUCTURED THIN
FILM, MESOPOROUS THIN
FILM, AND PROCESS FOR
PRODUCTION THEREOF

)
: Examiner: Hai Vo
)
: Group Art Unit: 1762
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)
: October 7, 2002

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

10/17/2002 SSITHIB1 00000027 09657616

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180.00 DP

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on
October 7, 2002
(Date of Deposit)

PETER SAXON

(Name of Attorney for Applicant)

Signature

October 7, 2002

Date of Signature

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. §1.97(c)(2).

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

Registration No.

24947

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